

Electronic Acknowledgement Receipt

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| EFS ID: | 4275221 |
| Application Number: | 10812354 |
| International Application Number: | |
| Confirmation Number: | 4104 |
| Title of Invention: | Method of improving the wafer to wafer uniformity and defectivity of a deposited dielectric film |
| First Named Inventor/Applicant Name: | Noriaki Fukiage |
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| Filer: | James Klekotka |
| Filer Authorized By: | |
| Attorney Docket Number: | 071469-0308969 (FKL-020) |
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| Application Type: | Utility under 35 USC 111(a) |

Payment information:

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| Submitted with Payment | yes |
| Payment Type | Deposit Account |
| Payment was successfully received in RAM | \$ 130 |

| RAM confirmation Number | 16093 | | | | |
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| Deposit Account | 503451 | | | | |
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| <p>The Director of the USPTO is hereby authorized to charge indicated fees and credit any overpayment as follows:</p> <p>Charge any Additional Fees required under 37 C.F.R. Section 1.16 (National application filing, search, and examination fees)</p> <p>Charge any Additional Fees required under 37 C.F.R. Section 1.17 (Patent application and reexamination processing fees)</p> | | | | | |
| File Listing: | | | | | |
| Document Number | Document Description | File Name | File Size(Bytes)/ Message Digest | Multi Part /.zip | Pages (if appl.) |
| 1 | Amendment/Req. Reconsideration-After Non-Final Reject | FKL-020_Amend_Notice_Of_Non-Compliance.pdf | <div>104768</div> <div>538651c129fd0ebe68b177f23d274490e178d0ea</div> | no | 12 |
| Warnings: | | | | | |
| Information: | | | | | |
| 2 | Fee Worksheet (PTO-06) | fee-info.pdf | <div>29855</div> <div>2c6652dadaa65d5ffaa095842c50a9653525a6a4</div> | no | 2 |
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| Information: | | | | | |
| Total Files Size (in bytes): | | | 134623 | | |
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